Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE			ATTY DOCKET NO. 124102			APPLICATION NO. New U.S. National Stage of PCT/FR03/003789			
INFORMATION DISCLOSURE STATEMENT										
(Use several sheets if necessary)					APPLICANTS Philippe ROBERT et al.					
					DATE 2005		·			
U.S. PATENT DOCUMENTS										
EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAM	E		CLASS	SUB CLASS	
/RC/	1	US 2002/0047172 A1	04/25/2002		Reid					
/RC/	2	5,582,678	12/10/1996		Komuro	•				
/RC/	3	5,430,421	07/04/1995		Bornand et al.					
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/RC/	4	WO 02/068321 A2	09/06/2002		WIPO					
/RC/	5	WO 00/33089 A2	06/08/2000		WIPO					
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)										
/RC/	6	Song et al.; "Wafer Level Vacuum Packaged De-Coupled Vertical Gyroscope By a New Fabrication Process";								
		Proceedings of the IEEE 13th Annual International Conference on Micro Electro Mechanical Systems; pp. 520-524;								
	XP010377181; January 23, 2000									
						3-1-1-1				
EXAMINER	/Rol	perts Culbert/			DATE CONSIDERED 06/04/2007					
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.										

Date: May 27, 2005